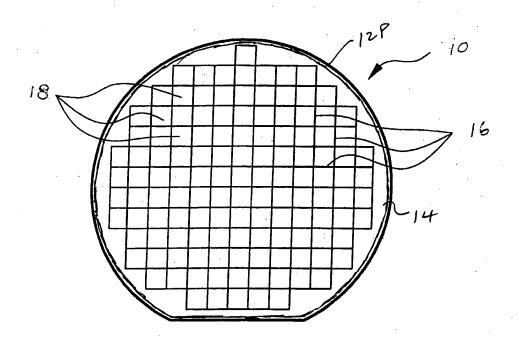
TITLE: METHOD AND APPARATUS FOR SUPPORTING WAFERS FOR DIE SINGULATION AND SUBSEQUENT HANDLING

Inventor: Farnworth et al. Serial No.: Not Yet Assigned Docket No.: 2269-5529US

1/4

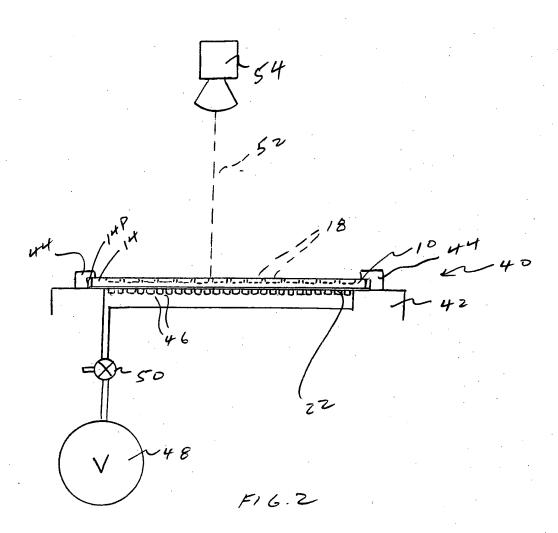
FIG. 1



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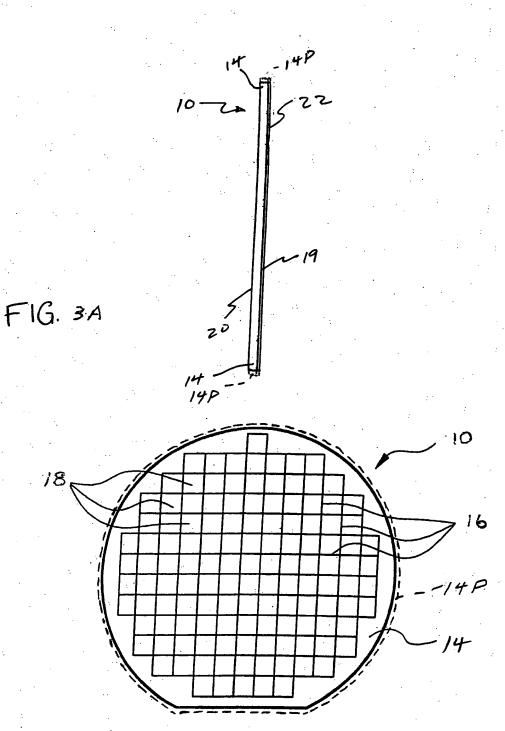
2/4



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3/4

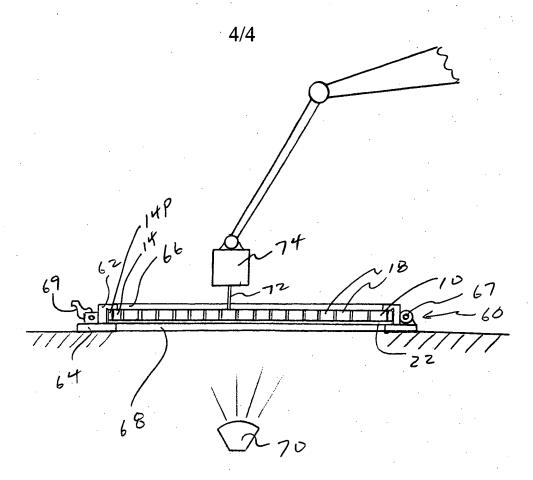


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18

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